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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

*(use as many sheets as necessary)*

Sheet	1	of	2
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**Complete if Known**

Application Number	09/705,447
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<b>Filing Date</b>	11/13/2000
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First Named Inventor	Miron
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Group Art Unit	2877
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Examiner Name	Lyons
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Attorney Docket Number	2965/MIRON/US
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## U.S. PATENT DOCUMENTS

[illegible]

**FOREIGN PATENT DOCUMENTS**

[illegible]

Examiner  
Signature

Date \_\_\_\_\_

**Considered**

Jan. 29, 1902

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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Sheet 2

of 2

### Complete if Known

Application Number	09/705,447
Filing Date	11/13/2000
First Named Inventor	Nicolae Miron
Group Art Unit	2877
Examiner Name	Lyons
Attorney Docket Number	2965/MIRON/US

### OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials <sup>*</sup>	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
MAZ		M. Born, E. Wolf, "Principles of Optics," Chapter 7.6, pp. 359-409, 7-th Edition, Cambridge University Press, Cambridge, 1999	
MAZ		A.G. Fox and T. Li, in "Resonant Modes in a Maser Interferometer," "The Bell System Technical Journal", pp. 453-488, March 1961	
MAZ		G.D. Boyd and K. Kogelnik, in "Generalized Confocal Resonator Theory", "The Bell System Technical Journal", pp. 1347-1369, July 1962	
MAZ		N. Chitica et al., "Monolithic InP-based Tunable Filter with 10-nm bandwidth for Optical data Interconnects in the 1550-nm Band," IEEE Photonics Technology Letters, vol. 11, No. 5, pp. 584-586, May 1999	
MAZ		A. Spisser et al., "Highly Selective and Widely Tunable 1.55- $\mu$ m InP/Air-Gap Micromachined Fabry-Perot Filter for Optical Communications," IEEE Photonics Technology Letters, vol. 10, pp. 1259-1261, Sept. 1998	
MAZ		P. Tayebati, et al., "Microelectromechanical Tunable Filter With Stable Half Symmetric Cavity," Electronics Letters, vol. 34 (1998), No. 20, pp. 1967-1968	
MAZ		D. Vakhshoori, et al., "2mW CW Singlemode Operation of a Tunable 1550nm Vertical Cavity Surface Emitting Laser With 50nm Tuning Range," "Electronics Letters", vol. 35 (1999), No. 11, pp. 900-901	
MAZ		K. Hirabayashi et al. "Tunable Liquid-Crystal Fabry-Perot Interference Filter for Wavelength-Division Multiplexing Communication Systems," "Journal of Lightwave Technology", vol. 11, No. 12, pp. 2033-2043, Dec. 1993	

Examiner  
Signature

*Will P. [Signature]*

Date  
Considered

Jan. 29, 2003

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